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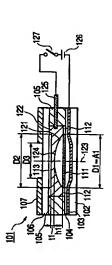
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(54) Optical element and optical device having it

(57) An optical element has a first fluid and an electroconductive or polar, second fluid immiscible with each other, which are confined in a sealed space created between a first support and a second support. The first fluid and the second fluid have respective light transmittances different from each other. By varying a

voltage applied to the second fluid, the shape of an interface between the first fluid and the second fluid is altered, so as to change an amount of light passing through the optical element.

FIG. 1



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filter, an apodization filter, a filter for correction for reduc-

Description

BACKGROUND OF THE INVENTION

Field of the Invention

[0001] The present invention relates to an optical element making use of the electrowetting phenomenon and, more particularly, to an optical element such as an optical filter capable of varying an amount of transmitted light, an optical switch capable of a titering an optical path (travelling direction) of incident light, or the like.

Related Background Art

(1002) The electrowetting phenomenon (also called electrocapilarity) is conventionally known as a phenomenon in which interfacial tension varies with application of a voltage to a liquid to cause migration or deformation of an interface. This electrowetting phenomenon will be described referring to Figs. 22A and 22B.

8 X electroconductive liquid droplet. Fig. 22A shows a state of capacitor is formed to accumulate electrostatic designates a substrate electrode, 502 an insulating layer formed on the substrate electrode 501, and 503 an in which no voltage is placed between the substrate age (V = V_0) is placed between the substrate electrode In Figs. 22A and 22B, reference numeral 501 electrode 501 and the droplet 503 (V = 0). When a volt-501 and the droplet 503, as Illustrated in Fig. 22B, a kind energy. This electrostatic energy changes the balance of surface tension of the droplet 503, whereby the shape of the droplet 503 varies from the state of Fig. 22A without application of the voltage. [0003]

[0004] The electroweiting phenomenon described as is utilized in the varifocal lens disclosed in WO98/18456 and in the electrocapilisty display sheet disclosed in Japanese Patent Application Laid-Open No. 9-311643. Then is, however, no known example of application to the other optical elements, for example, the optical elements such as the optical filter capable of varying the amount of transmitted light, the optical switch capable of altering the optical path (traveling direction) of incident filtipt, and so on.

SUMMARY OF THE INVENTION

[0005] An object of the present invention is to provide an optical element with a function making use of the electrowetting phenomenon, which has never been known heretofore, and, particularly, to provide an optical element such as an optical filter capable of varying the amount of transmitted light, an optical switch capable of attering the optical path (traveling direction) of incident light, or the like.

[0006] In an embodiment of the present Invention for accomplishing the above object, an optical element is one suitably applicable, for example, to a variable ND

tion of marginal light amount, and so on, which complisss a first support, a second support, a first fluid, and an electroconductive or polar, second fluid having an optical transmittance different from that of the first fluid, said first and second fluids being confined in a sealed space created between the first support and the second support, said first and second fluids being immiscible with each other, wherein by varying a voltage applied to the second fluid the shape of an interface between the first fluid and the second fluid is altered, so as to change an amount of light passing through the optical element.

In another embodiment of the present invention an optical element is one suitably applicable, for example, to an optical switch capable of altering the optical path (traveling direction) of incident light or the a first fluid, and an electroconductive or polar, second fluid, said first and second fluids being confined in a sealed space created between the first support and the second support, said first and second fluids being applied to the second fluid, the shape of an interface between the first fluid and the second fluid is altered, so as to change an optical path of incident light entering like, which comprises a first support, a second support, Immiscible with each other, wherein by varying a voltage the optical element. 0007 5 8

BRIEF DESCRIPTION OF THE DRAWINGS

[0008]

Fig. 1 is a cross-sectional view of an optical element of Embodiment 1;

Fig. 2 is a diagram to explain the operation with application of the voltage to the optical element of Embodiment 1;

Fig. 3A, Fig. 3B, and Fig. 3C are detailed diagrams to explain the operation of the optical element of Embodiment 1;

Fig. 4 is a diagram to explain the transmittance of the optical element of Embodiment 1; Fig. 5 is a diagram to show the structure of a photographing device incorporating the optical element of Embodiment 1;

Fig. 6 is a control flowchart of the photographing device incorporating the optical element of Embodiment 1;

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Fig. 7A, Fig. 7B, and Fig. 7C are detailed diagrams to explain the operation of an optical element of Embodiment 2:

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criticoninents, Fig. 8 is explain the transmittance disrigue, in the optical element of Embodiment?. Fig. 9 is a diagram to show the structure of a photographing device incorporating the optical element

of Embodiment 2; Fig. 10 is a control flowchart of the photographing device incorporating the optical element of Embod-

Fig. 11A and Fig. 11B are detailed diagrams to explain the operation of an optical element of Fig. 12 is a diagram to explain the transmittance of Fig. 13 is a diagram to show the structure of a photographing device incorporating the optical element the optical element of Embodiment 3; of Embodiment 3;

Fig. 14 is a control flowchart of the photographing device incorporating the optical element of Embod-

grams to expisin the operation of an optical element Fig. 15A, Fig. 15B, and Fig. 15C are detailed diaof Embodiment 4;

Fig. 16 is a diagram to explain the transmittance distribution of the optical element of Embodiment 4; tographing device incorporating the optical element Fig. 17 is a diagram to show the structure of a phoof Embodiment 4;

Fig. 18 is a control flowchart of the photographing device incorporating the optical element of Embodiment 4; Fig. 19A and Fig. 19B are cross-sectional views of an optical switch in Embodiment 5; Fig. 20A, Fig. 20B, and Fig. 20C are cross-sectional Fig. 21A and Fig. 21B are cross-sectional views of views of an optical switch in Embodiment 6;

change of the droplet between before and after the Fig. 22A and Fig. 22B are diagrams to show application of voltage, for explaining the electrowetan optical switch in Embodiment 7; and ting phenomenon.

hydrophilic film 112 thereon.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

First, embodiments of the optical filter capable of varying the amount of transmitted light will be described. It is, however, noted that the present invention is by no means intended to be limited to only these

[Embodiment 1]

ŧ Fig. 1 to Fig. 5 are drawings for explaining the optical element according to Embodiment 1 of the present invention. 0010

8 Fig. 1 is a cross-sectional view to show the structure of the optical element in Embodiment 1 of the present invention.

The structure of the optical element and a optical element of the present invention and 102 a transparent substrate of transparent acrylic resin having a production method thereof in the present embodiment Numeral 101 designates the whole of the will be described below referring to Fig. 1. [0013] [0012]

A transparent electrode of indlum tin oxide 0014]

ecess in the center.

(ITO) 103 is formed by sputtering on the upper surface 104 of transparent acrylic resin is formed in contact with of the transparent substrate 102, and an insulating layer the upper surface of the electrode 103.

ping the replica resin into the center of the transparent electrode 103, pressing a glass sheet thereonto to smooth the surface, and thereafter exposing the resin to UV light to cure it. A cylindrical vessel 105 with a shielding property is bonded and fixed to the upper surface of the insulating layer 104, a cover sheet 106 of transparface of the vessel 105, and a stop sheet 107 having an aperture of the diameter D3 in the central part is further The insulating layer 104 is formed by dropent acrylic resin is bonded and fixed to the upper surplaced on the upper surface of the cover sheet 106. [0015]

[0016] In the above structure, a housing is formed with a sealed space or liquid chamber of a predetermined volume surrounded by the insutating layer 104,

The wall surfaces of the liquid chamber are vessel 105, and upper cover 106. [0017]

First, a water-repellent agent is delivered Into the range of the diameter D1 on the central area of the upper surface of the insulating layer 104 to form a The water-repellent agent is preferably one selected from fluorine compounds and the like. A hydrophilic agent is also delivered into the range outside the diameter D1 on the upper surface of the insulating layer 104 to form a treated by a surface treatment described below. water-repellent film 111 thereon. [0018]

selected from surfactants, hydrophilic polymers, and so the range of the diameter D2, to form a hydrophilic film 113 having the property similar to that of the hydrophilic film 112. All the components described heretofore have the rotationally symmetric shape with respect to the optical axis 123. Further, a hole is made in part of the vessel 105 and a rodlike electrode 125 is inserted into the hole. Then the hole is sealed with an adhesive to maintain the hermetic sealing of the liquid chamber. A power supply 126 is connected to the transparent electrode 103 and to the rodlike electrode 125, whereby a predetermined voltage can be placed between the two The hydrophilic agent is preferably one on. On the other hand, the lower surface of the cover sheet 106 is treated by a hydrophilic treatment within [0019]

Two types of liquids described below are First, a predetermined amount of the first liquid 121 is dropped onto the water-repellent film 111 on the insulating layer 104. The first liquid 121 is silicone oil which is colorless and transparent and which has the specific gravity of 0.85 and the refractive index of 1.38 at room charged into the liquid chamber of the above structure. electrodes according to control of switch 127. [0050]

On the other hand, the second liquid 122 is The second liquid 122 is an electroconductive electrolyte which is made by mixing water and ethyl charged into the rest space in the liquid chamber. [0021] [0022]

alcohoi at a predetermined ratio and further adding a soluble dye, for example carbon black or a titanium uid 122. Namely, the first and second liquids selected are the liquids which are immiscible with each other and which have the substantially equal specific gravities and predetermined amount of salt thereto and which has the specific gravity of 0.85 and the refractive index of 1.38 at room temperature. In addition, an achromatic, wateroxide base material, is further added to the second Ilqrefractive indexes, but have different ray absorptive

Next, the shape of the interface will be described. [0023]

ent of each other.

powers. Therefore, the two liquids form an interface 124 and do not intermix, so that the liquids exist independ-

ond liquid, the shape of the interface 124 is determined repellent film 111 or the hydrophilic film 112 on the insuond liquid and the water-repellent film 111 or the First, when no voltage is applied to the secby the interfacial tension between the two figuids, the interfacial tension between the first liquid and the waterlating layer 104, the interfacial tension between the sechydrophilic film 112 on the insulating layer 104, and the volume of the first liquid. [0024]

In the present embodiment, the materials tively smaller between the silicone oil being the material are selected so as to make the interfacial tension relaof the first liquid 121, and the water-repellent film 111. [0025]

two materials, the outer edge of the lens-shaped droplet bilized when the outer edge coincides with the coating first liquid is equal to the diameter D1 of the water-repel-Namely, since wettability is high between the of the first liquid 121 tends to expand and becomes staarea of the water-repellent film 111. In other words, the diameter A1 of the bottom surface of the droplet of the [0026]

the gravity does not act. Therefore, the interface 124 becomes spherical and the radius of curvature and the height h1 thereof are determined by the volume of the On the other hand, since the specific gravities of the two liquids are equal as described previously, first liquid 121.

is brought to the closed position to apply the voltage to the interfacial tension between the second liquid 122 and the water-repellent film 111 into the area of the The thickness of the second liquid is t1 on the optical axis. On the other hand, when the switch 127 the second liquid 122, the electrocapillarity decreases and the hydrophilic film 112, so that the second liquid moves over the border between the hydrophilic film 112 water-repellent film 111. [0028]

ster of the bottom surface of the droplet of the first liquid As a result, as illustrated in Fig. 2, the diam-121 decreases from A1 to A2 and the height thereof increases from h1 to h2.

The thickness of the second liquid 122 becomes t2 on the optical axis. As described, the balance of interfacial tension between the two types of liq-

uids varies depending upon the application of voltage to the second liquid 122, so as to after the shape of the interface between the two liquids.

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path lengths where the fight travels through the second emerging from the transparent substrate 102. Namely, a thickness of the second liquid on the optical axis (t1 of 126. Since the refractive indexes of the first and second The first liquid 121 is substantially transparthe light is absorbed by amounts according to optical liquid 122. This decreases the intensity of the light decrease rate of light intensity is proportional to the Fig. 1 or t2 of Fig. 2). This substantlates the optical eleamount by aftering the shape of the interface 124 according to the voltage control of the power supply liquids are substantially equal to each other, the incident light is modified only in the intensity of emerging light, ent, whereas the second liquid 122 has the predetermined ray absorptive power because of the lightabsorbing material added thereto. Therefore, when light is incident through the aperture of the stop plate 107, ment capable of freely varying the transmitted light without changing the direction thereof.

Fig. 3A shows a situation in which the output voltage of the power supply 126 connected to the optical Next, the operation of the above optical element used as a variable ND filter will be described in furelement 101 is V1 equal or close to zero. ther detail, based on Figs. 3A to 3C. [0032] [0033]

The shape of the interface 124 at this time is the same as illustrated in Fig. 1, the diameter of the bottom surface of the lens formed of the first liquid 121 is A1, and the height thereof is h1. [0034]

The thickness on the optical axis of the secand liquid is t1. Lin represents light coming from above the optical element 101 and entering the aperture of the stop 107, and Lour light emerging from the optical element 101 [0035]

tance of the optical element 101, and the transmittance A ratio of the fight Lour to Lin is the transmitat this time is low, because the thickness t1 on the optical exis of the second liquid is large. [0036]

The light amount distribution of the output fight Lour demonstrates decrease in the light amount with increase in the distance from the optical axis, i.e., with increase in the incident height, but the light amount distribution of the output light Lour can be regarded as almost uniform, because the aperture diameter D3 of the stop 107 is smaller than the diameter A1 of the bot-Namely, optical path lengths of respective rays passing through the aperture of the stop 107 and then through the first liquid 121 and the second liquid 122 are approximately (substantially) equal, independent of the positom surface of the droplet formed of the first liquid 121. tions where the rays pass in the aperture. 8 ŧ

Fig. 3B shows a situation in which the output voltage of the power supply 126 is V2 greater than V1. At this time, the diameter of the bottom surface of the droplet of the first liquid 121 is A2 and the height is h2.

The thickness on the optical axis of the secand liquid 122 is t2 smaller than t1 of Fig. 3A. The transmittance of light is thus greater than that in the case of Fig. 3C shows a situation in which the output voltage of the power supply 126 is V3 further greater than V2. At this time, the diameter of the bottom surface of the droplet of the first liquid 121 is reduced to A3 and the top of the interface 124 becomes flat in contact with the hydrophilic film 113 formed on the bottom surface of [000

the second liquid 122 is zero and thus the transmittance Then the diameter of this flat part is equal to or larger than the diameter D3 of the aperture of the stop 107. As a result, the thickness on the optical axis of is further greater than in the case of Fig. 3B. the cover sheet 106.

aperture of the stop 107. Therefore, the transmittance is kept constant where the optical element is used as a With further increase in the output voltage of the power supply 126 thereafter, there appears no change in the shape of the interface 124 inside the variable ND filter. The transmittance at this time is expressed by the product of the transmittances of the Insulating layer 104, water-repellent film 111, first liquid transparent substrate 102, transparent electrode 103, 121, hydrophilic film 113, and cover sheet 106. [0042]

ply 128 is switched from the state of Fig. 3C back to V1, the interfacial tension between the two liquids returns to the initial value. At this time, the wettability is good to the state of Fig. 3A. Namely, the shape afteration of between the second liquid 122 and the hydrophilic film 113, while the wettability is poor between the first liquid 121 and the hydrophilic film 113. Therefore, the first liquid 121 moves away from the hydrophilic film 113 back the interface 124 of the optical element is reversible When the applied vottage of the power supagainst the variation of applied voltage. [0043]

is here meant the "average value of transmittance" of becomes saturated when the applied voltage arrives at tance of the optical element 101 against voltage applied to the optical element 101. By "transmittance" in Fig. 4 continuously increases with increase in the applied voltage and the variation of transmittance Fig. 4 shows the relationship of ray transmitthe entire area within the diameter D3. The transmittance

ing device 141 will be described as an example of a so-Fig. 5 shows an application example of the In the present embodiment, the photographcally convert a still image to electrical signals by image called digital still camera constructed to photoelectrioptical element 101 to the photographing apparatus. pickup means and record them as digital data. [0045] [0046]

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cal system consisting of a plurality of lens units, which are a first lens unit 131, a second lens unit 132, and a Numeral 130 denotes a photographing optithird lens unit 133.

The focus is adjusted by moving the first lens [0048]

Zooming is effected by moving the second unit 131 back and forth in the optical-axis directions. [0049]

The third lens unit 133 is a relay lens unit

which is fixed.

lens unit 132 back and forth in the optical-exts direc-

The optical element 101 is disposed between the second lens unit 132 and the third lens unit [0051]

The image pickup means 134 is placed at photographing optical system 130. This means is a photoelectric conversion means such as a two-dimensional electric conversion portions for converting optical energy of incident light into charge, charge storage portions for storing the charge, and a charge transfer section for accepting the charge transferred thereto and focal-point position (intended image plane) of the CCD sensor or the like consisting of a plurality of phototransmitting the charge to the outside.

ing unit (hereinafter referred to as CPU) for controlling is a one-chip microcomputer having the ROM, RAM, EEPROM, A/D conversion function, and D/A conversion function. Numeral 143 indicates a power source for supplying power to the CPU 142 and to various circuits and Numeral 142 represents a central processthe operation of the entire photographing device, which actuators in the photographing device. [0023]

Numerai 144 denotes a power supply means which correspond to the power supply 126 of Fig. 1. The power supply means 144 outputs a desired voltage for applying the voltage to the optical element 101 according to a control signal from the CPU 142. [0054]

Numeral 145 designates an image signal processing circuit which performs A/D conversion of analog image signals supplied from the photoelectric processing thereof, such as the AGC control, white balconversion means 134 and then performs image ance, y correction, edge enhancement, and so on. [0055]

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Numeral 151 denotes a monitor such as a Ilquid crystai display or the like, which displays an object image acquired by the photoelectric conversion means 134 and the operation circumstances of the photographing device. [0056]

Numeral 152 represents control switches, which include a main switch for activating the CPU 142 from a sleep state to a program execution state, a photograph preparation switch, a photograph start switch, a photograph condition setting switch for setting of shutter speed or the like, and so on. [0057]

Numeral 153 denotes a zoom driver which tion according to photographer's manipulation on a zoom switch to vary the focal iength of the photographing optical system 130. Numerai 154 represents a focus detector which is preferably a phase difference detecconsists of an actuator and a driver circuit for moving the second tens unit 132 back and forth in the optical. axis directions and which performs the zooming operation type focus detecting means or the like used in sin-[0058]

CPU leaves step S104 to execute the processes in and after step S111.

pickup means 134 and signal processing circuit 145 to acquire a preview image. The preview image is an image which is acquired before photography in order to permit proper setting of the photographing conditions for a finally recorded image and permit the photogra-In step S111 the CPU drives the image pher to capture the photographing composition.

cai-axis directions and which performs the focusing

Numeral 155 indicates a focusing driver which consists of an actuator and a driver circuit for moving the first lens unit 131 back and forth in the optioperation based on a focus signal computed by the ocus detector 154 to adjust the focus condition of the

gle-lens reflex cameras.

Numeral 158 stands for a memory, which saves image signals of taken images. Specifically, the

photographing optical system 130.

In step S112 the CPU determines a light amount level of the preview image acquired in step [0071]

signals outputted from the image pickup means 134 and determines the amount of incident light to the image Specifically, the CPU calculates maximum, minimum, and average output signal levels of the image In step S113 the CPU determines whether pickup means 134. [0073] [0072] 5

> The dynamic range of luminance of objects existing in nature is very wide and, in order to set it in a

predetermined range, it is common practice to provide the photographing optical system with a mechanical stop mechanism inside and adjust the amount of photo-

Next, the action of the optical element 101 in

the present embodiment will be described below.

memory 156 is preferably a detachable PC card type

lash memory or the like.

[0061] [0062] the light amount level determined in step S112 above is if it is judged as proper in this step, the CPU [0074]

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However, it is hard to make the size of the mechanical stop mechanism smaller and the resolving

graph light.

[0063]

power of object image is degraded by diffraction of light at the edge of stop wings in a small stop state where the

In step S114 the preview image acquired in step S111 is displayed on the monitor 151 moves to step \$114. [0075]

Then the CPU goes to step S115 to detect the focus condition of the photographing optical system 130 by use of the focusing detector 154. In next step S116 the CPU makes the focus driver 155 drive the first lens unit 131 back and forth in the optical-axis directions so as to perform the focusing operation. After that, the CPU proceeds to step S117 to determine whether the photograph switch (denoted by SW2 in the flowchart) [0076]

When the optical element 101 is used as a

stop aperture is small.

variable ND filter replacing the above mechanical stop mechanism as in the present embodiment, the amount tem can be adjusted in a proper range, without experi-Fig. 6 is a control flowchart of the CPU 142 which the photographing device 141 illustrated in Fig. 5

encing the above drawbacks.

[0065]

of light passing through the photographing optical sys-

As long as the photograph switch is off, the CPU goes back to step S111 to repeatedly carry out the steps from the acquirement of preview image to the becomes on. [00] focusing.

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Through step S101, the CPU goes to step

the main switch on. The CPU stays at step S102 as long

as the main switch is off.

S102 to determine whether the photographer switches

has. The control flow of the photographing device 141

will be described below referring to Fig. 5 and Fig. 6.

Once it is determined in step S102 that the

main switch becomes on, the CPU 142 leaves the sleep

state to execute the processes in and after step \$103.

photographer sets an exposure control mode (shutter

ng conditions set by the photographer. Specifically, the priority AE, program AE, etc.), an autofocus mode (one shot AF, continuous AF, etc.), a drive mode (single shot, number of recording pixels used, an image compres-

In step S103 the CPU accepts photograph.

[9900

continuous shots, etc.), an image quality mode (the sion rate selected, etc.) and so on by use of the monitor In step S104 the CPU determines whether the photographer switches the photograph preparation

151 and the control switches 152.

When it is determined in step S113 on the other hand that the light amount level judged in step In step S121 the CPU compares the actual light amount level with the proper light amount level and calculates the proper transmittance of the optical ele-S112 above is not proper, the CPU jumps to step S121. ment 101 in the photographing optical system 130. [0079] [0078]

In step S122 the CPU calculates the control voltage for achieving the proper transmittance calculated in step S121 above. Specifically, since the ROM of the CPU 142 stores a look-up table indicating the relation of transmittance against applied vottage illustrated In Fig. 4, the CPU references the table to determine the applied voltage against the transmittance calculated in step S121. [080] ş

In step S123 the CPU controls the output voltage of the power supply means 144 so as to apply the voltage acquired in step S122 above to the optical element 101. After execution of step S123, the CPU returns to step S111 to repeatedly carry out the steps from the acquisition of preview image to the power sup-

> switch (denoted by SW1 in the flowchart) on. As long as the photograph preparation switch is off, the CPU goes

pack to step S103 to accept the set photographing conditions repeatedly. Once it is determined in step S104 that the photograph preparation switch becomes on, the

version of the analog image signals accepted and the image processing including the AGC control, white balobtained in step S133 above are stored in the memory When the photographer switches the photograph switch on during the repetitive execution of the photograph preparation operation as described above, the CPU jumps from step S117 to step S131. In step Specifically, the object image formed on the image means 134 is photoelectrically converted to store the charge proportional to the intensity of optical mage in the charge storage section in the vicinity of stored in step \$131 is read out through the charge the signal processing circuit 145 performs the A/D conγ correction, edge enhancement, and so on. Further, JPEG compression or the like is effected according to an image compression program stored in the CPU 142 if necessary. In step S134 the image signals 156 and the photographing operation is complete in S131 the CPU performs the Image pickup operation. each photoreceptive portion. In step S132, the charge transfer line and the analog signals thus read are supplied to the signal processing circuit 145. In step S133, step S135.

As described above, Embodiment 1 realizes the optical element or the photographing device that can present the excellent effects in the following points.

- It can provide the ND filter capable of continuously controlling the light transmittance to any desired value by controlling the applied voltage to the opti-
- The use of the optical element instead of the mechanical stop mechanism of the photographing means such as the stop wings, stop aperture control mechanism, etc. and also permits continuous control of the level of Incident light to the Image pickup means, thus permitting achievement of smaller size and higher performance of the photooptical system permits disuse of the mechanical graphing apparatus.

Embodiment 2]

transmittance-variable optical element was described as the example of the variable ND filter, whereas in Embodiment 1 described above, the Embodiment 2 is an example of a transmittance-distribution-variable filter demonstrating a transmittance distribution in which the transmittance gradually decreases with increase in the incident height (the distance from the optical axis) of the incident light to the optical element and being capable of controlling the transmittance distribution to a desired profile by controlling the applied roftage to the optical element.

Figs. 7A, 7B, and 7C to Fig. 10 are drawings for explaining Embodiment 2 of the present invention, and Figs. 7A to 7C are drawings for detalling the operation where the optical element of the present embodiment is used as a transmittance-distribution-variable

ment 201 is set to be greater than the diameter D3 of In the present embodiment, the diameter D4 of the aperture of the stop plate 207 in the optical elethe aperture of the stop plate 107 in Embodiment 1 and the other members in the present embodiment all have the same functions and dimensions as in Embodiment Therefore, the same portions will be denoted by the same reference numerals and redundant description will be avoided. [0086]

voltage of the power supply 126 connected to the optical [0087] Fig. 7A shows a situation in which the output element 201 is V1 equal to or close to zero.

The shape of the interface 124 at this time is the same as in Fig. 3A, the diameter of the bottom surface of the droplet formed of the first liquid 121 is A1, and the height is h1. [0088]

The thickness on the optical axis of the second liquid 122 is t1. Lin represents the light coming from above the optical element 201 and entering the aperture of the stop 207, while L_{OUT} the light emerging from the optical element 201. [6800]

Since the present embodiment has the of the droplet of the first figuid 121 is the same as in Embodiment 1 but the aperture diameter D4 of the stop Lour is not uniform and the amount of transmitted light considerably decreases with increase in the distance structure in which the diameter A1 of the bottom surface 207 is larger than the aperture diameter D3 in Embodiment 1, the light amount distribution of the output light from the optical axis 123. [0600]

Fig. 7B shows a situation in which the output voltage of the power supply 126 is V2 larger than V1. At let of the first liquid 121 is A2 and the height is h2. An average of transmitted light amount is larger than in Fig. 7A and the nonuniformity of transmitted light amount becomes more prominent. Fig. 7C shows a situation in which the output voltage of the power supply 126 is V3 this time, the diameter of the bottom surface of the dropfurther greater than V2. [009]

At this time, the diameter of the bottom surface of the droplet of the first liquid 121 is decreased to A3, and the top of the interface 124 becomes flat in contact with the hydrophilic film 113 formed on the bottom surface of the cover sheet 106. [0092]

The diameter of this flat part is smaller than the diameter D4 of the aperture of the stop 207. As a result, the transmittance becomes uniform in the region inside the flat part, but it gradually decreases according to the distance from the optical axis in the outside region. The transmittance at the incident height of zero tances of the transparent substrate 102, transparent at this time is expressed by the product of the transmit-[0093]

electrode 103, insulating layer 104, water-repellent film 111, first liquid 121, hydrophilic film 113, and cover

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of transmittance distribution against incident height (the distance from the optical axis 123) of the incident light to Fig. 8 is a diagram to show the relationship the optical element 201, using the parameter of the voltage applied from the power supply 126 to the optical With increase in the applied voltage, the average transmittance increases and absolute values of gradients also increase on the transmittance curve in which the transmittance gradually decreases with

Fig. 9 shows an application example of the optical element 201 to the photographing apparatus. In halide film camera for projecting a still image onto a silthe present embodiment, the photographing device 241 will be described as an example of the so-called silverincrease in the incident height. ver-hallde film. [9600]

the same as that of each lens unit 131, 132, or 133 in Numeral 230 designates the photographing and a third lens unit 233, the function of each of which is the photographing device 141 in Embodiment 1 of Fig. optical system consisting of a plurality of lens units, which are a first lens unit 231, a second lens unit 232, [0097]

a mechanical stop mechanism 234 incorporating a the second lens unit 232 and the third lens unit 233 and stepping motor as a driving source is disposed behind The optical element 201 is placed between the optical element 201. The silver film 236 is located at the focal point of the photographing optical system 230 and a focal-plane shutter 235 is placed immediately

winding up the film 236. Numeral 246 designates an The power source 143 and the power supply means 144 the same reference numerals. Numeral 245 indicates a charging an actuation spring of the aforementioned focal-plane shutter 235 and a rewinding mechanism for tion of object, which is composed of a focusing screen, Numeral 242 represents the CPU for controlare the same as in Embodiment 1 and thus denoted by mechanical charger which consists of a mechanism for optical finder system for forming an image for observaling the operation of the entire photographing device, which is a one-chip microcomputer having the ROM, RAM, EEPROM, and A/D and D/A conversion functions. a pentagonal roof prism, and an eyeplece. [6600]

and the path to the finder optical system 246, and an Numeral 247 denotes a quick return mirror ror for switching of light between the path to the film 236 disposed between the third lens unit 233 and the focalplane shutter 235, which is composed of a movable miractuator for actuating the mirror. [010<u>0</u>

Numeral 251 represents the monitor such as

he liquid crystal display or the like, which displays the

operation circumstances of the photographing device.

include the main switch for activating the CPU 242 from the photograph condition setting switch for setting of the sleep state to the program execution state, the pho-Numeral 252 indicates the control switches, which tograph preparation switch, the photograph start switch, shutter speed or the like, and so on. The apparatus of the present embodiment is present embodiment has an apodization effect input different from Embodiment 1 in that the apparatus of the The zoom driver 153, the focus detector 154, switch described hereinafter.

and the focusing driver 155 have the same functions as those in Embodiment 1 and thus are denoted by the which is comprised of a photometry sensor disposed in the middle of the finder optical system 246 and an out-Numeral 256 denotes a photometry means, put amplifier for amplifying output of the sensor. same reference symbols.

Next, the action of the optical element 201 in When an object with some depth is imaged the present embodiment will be described below. [0106] When an object with some depth is in [0105]

on the film 236 by the photographing optical System 230, the object image in focus can be represented by an assembly of point images, but the object image out of focus, so called an out-focus image, is an assembly of blurred images having finite diameters. ĸ

When the photographing optical system is an aplanatic lens system, the blurred images are circu-However, the practical lenses have various aberrations and consequently disturb the blurred lar images with uniform illuminance. [0107] [0108]

anese Patent Application Laid-Open No. 9-236740, that images, for example, like a lens presenting a dirty blur mittance of which gradually decreases with increase in the incident height, is placed near the stop of the photographing optical system, so as to obtain a natural blurred image without incompatibility. The present It is thus contemplated, as disclosed in Japan optical element, called an apodization filter the transembodiment accomplishes the function of the apodizaeffect as called off-axis aberration. [0109] \$

Fig. 10 is a control flowchart of the CPU 242 The control flow of the photographing device in the photographing device 241 illustrated in Fig. 9. tion filter by the optical element 201. [011] 0110

241 will be described below referring to Fig. 9 and Fig. Through step S201, the CPU goes to step S202 to determine whether the photographer switches [0112]

the main switch on. While the main switch is off, the

When it is determined in step S202 that the main switch becomes on, the CPU 242 leaves the sleep In step S203 the CPU accepts the photographing conditions set by the photographer. Specifically, the photographer sets the exposure control mode state to execute the processes in and after step S203. CPU stays at step S202. [0113]

(shutter priority AE, program AE, etc.), the autofocus

mode (one shot AF, continuous AF, etc.), the drive mode (single shot, continuous shots, etc.) and so on by use of the monitor 251 and the control switches 252.

In step S204 the CPU accepts selection of the apodization effect by the photographer. Specifically, the photographer selects an apodization level by use of to "3". The apodization effect becomes more prominent the monitor 251 and the apodization effect selection switch among the control switches 252. Specifically, one apodization level can be selected from the levels of "1" as the level number increases.

in step S204 above. Specifically, when level 1 is selected, the appilled voltage to the optical element 201 is set to V1. Likewise, the applied voltage is set to V2 with selection of level 2 and to V3 with selection of level In step S205 the CPU calculates the applied voltage corresponding to the apodization level selected [0116]

8 above is supplied from the power supply means 144 to Similarly, the characteristics corresponding to the In step S206, the voltage set in step S205 pher selects the apodization level 1, the transmittance distribution of the optical element 201 becomes the curve indicated by the applied voltage V = V1 in Fig. 8. applied voltage V = V2 are obtained with selection of evel 2, and the characteristics corresponding to the the optical element 201. As a result, when the photograapplied voltage V = V3 with selection of level 3. [0117]

In step S207 it is determined whether the grapher switches the photograph preparation switch (indicated by SW1 in the flowchart) on. While the photograph preparation switch is off, the CPU goes back to step S203 to repeatedly accept the setting of photographing conditions and the selection of apodization effect. When it is determined in step S207 that the photograph preparation switch becomes on, the CPU leaves step S207 to execute the processes in and after step S211. [0118]

detected by the photometry means 256. The shutter In step S211 the luminance of object is speed and aperture upon photography are calculated gram chart stored in the ROM. In step S213 the focus condition of the photographing optical system 230 is detected by the focus detector 154. In next step S214, the first lens unit 231 is moved back and forth in the optical-axis directions by the focus driver 155 to perform the based on the object luminance detected and the profocusing operation.

After that, the CPU goes to step S215 to nine whether the photograph switch (represented by SW2 in the flowchart) is switched on. While the photograph switch is off, the CPU goes back to step S211 to repeatedly carry out the steps from photometry to 0120

graph switch on during the repetitive execution of the When the photographer switches the photophotograph preparation operation as described above, the CPU Jumps from step S215 to step S231.

In step S231 the quick return mirror 247 is retracted out of the photograph light. [0122]

In step S233 the focal-plane shutter 235 is In step S232 the stop 234 is controlled based on the aperture calculated in step S212. [0123] [0124]

In step S234 the quick return mirror 247 is culated in step S212. [0125]

actuated and controlled based on the shutter speed cal-

returned into the photograph light and the stop 234 is In step S235 the charger 245 is actuated to also taken back into the open state. [0126]

charge the focal-plane shutter 235 into the initial state (wing-movable state) and the film 236 is wound up by one frame. Then the photographing operation is com-[0127] Embodiment 2 described above can subplete in step S236.

stantiate the optical element or the photographing device that can present the excellent effects in the following points.

ing the transmittance distribution in which the the incident height of the incident light to the optical tance distribution to a desired profile by controlling The present embodiment can provide the transmittance-distribution-variable filter capable of achlevtransmittance gradually decreases with increase in element and capable of controlling the transmitthe applied voltage to the optical element.

graphing apparatus capable of optionally controlling the blur effect of the out-focus image (so-called the blurred image) by placing the optical element near The present embodiment can provide the photothe stop mechanism of the photographing optical system, and thus capable of obtaining a high-qual-

[Embodiment 3]

[0128] Embodiment 1 and Embodiment 2 described above were the examples of the filters constructed to continuously vary the transmittance, whereas Embodistructed to switch between a light-transmitting state and ment 3 shows an example of the transmittance-variable optical element applied as an optical shutter cona light-intercepting state. \$ ŧ

Figs. 11A, 11B to Fig. 14 are drawings for Figs. 11A and 11B are diagrams to detail the operation where the optical element is used as an optical shutter explaining Embodiment 3 of the present invention and in the present embodiment. [0129]

tion of the water-soluble dye dissolved in the second liquid 322 is greater than in Embodiment 1, so as to all have the same functions and same dimensions as in In the present embodiment, the concentraincrease the light absorptive power. The other members Embodiment 1. Therefore, the same portions will be denoted by the same numbers and redundant description will be avoided. [0130]

132, or 133 in the photographing device of the first 8 EP 1 069 450 A2 Fig. 11A shows a situation in which the out-

embodiment of Flg. 5.

put power of the power supply means 126 connected to

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the optical element 301 is V1 equal to or close to zero. The shape of the interface 124 at this time is the same droplet of the first liquid 121 is A1, and the height is h1.

as in Fig. 3A, the diameter of the bottom surface of the The thickness on the optical axis of the second liquid 322 is 11. Lin represents the light coming from above the optical element 301 and entering the aperture of the stop 107. In the present embodiment, since the light the amount of emerging light will become almost zero even if the thickness t1 on the optical axis of the second

The optical element 301 is interposed between the second lens unit 332 and the third lens unit 333 and the mechanical stop mechanism 334 using a stepping motor as a driving source is placed behind the optical element 301.

The structure of the other members is the same as in Embodiment 1 and the same members will be denoted by the same reference numerals while omitting the description thereof. [0138]

tion between transmission and interception of light are [0139] In the present embodiment the mechanical stop mechanism 334 is used in addition to the optical son thereof is that the fine adjustment function of light amount of photographing light and the switching funcelement 301 as an optical shutter member and the reaimplemented by the separate members.

> Fig. 11B shows a situation in which the output voltage of the power supply means 126 is the same surface of the droplet of the first liquid 121 is reduced to A3 and the top of the interface 124 becomes flat in contact with the hydrophilic film 113 formed on the bottom surface of the cover sheet 106. The diameter of this flat part is larger than the diameter D3 of the aperture of the stop plate 107. As a result, the transmittance distribution becomes uniform Inside the aperture diameter D3 voltage of the power supply means 125 thereafter, the shape of the interface 124 does not vary inside the aperture of the stop plate 107 and thus the transmittance is constant where the optical element is used as expressed by the product of the transmittances of the insulating layer 104, water-repellent film 111, first fiquid 121, hydrophillc film 113, and cover sheet 106. Since the transparent materials are selected for these members, the overall transmittance is high, i.e., the optical

[0132]

liquid 322 is considerably small.

as V3 of Fig. 3C. In this case, the diameter of the bottom

absorptive power of the second liquid 322 is very high,

Fig. 14 is a control flowchart of the CPU 342

[0140]

in the photographing device 341 illustrated in Fig. 13.

[0141] The control flow of the photographing device [0142] Through step S301, the CPU goes to step S302 to determine whether the photographer switches the main switch on. While the main switch is off, the 341 will be described below referring to Fig. 13 and Fig. ĸ

of the stop plate 107. With further increase in the output

an optical shutter. The transmittance at this time is

transparent substrate 102, transparent electrode 103,

(shutter priority AE, program AE, etc.), the autofocus mode (one shot AF, continuous AF, etc.), the drive mode When it is determined in step S302 that the main switch becomes on, the CPU 342 leaves the sleep (single shot, continuous shots, etc.), the image quality mode (the number of recording pixels used, the image compression rate selected, etc.) and so on by use of the [0144] In step S303 the CPU accepts the photocally, the photographer sets the exposure control mode graphing conditions set by the photographer. Specifistate to execute the processes in and after step S303. monitor 151 and the control switches 152. CPU stays at step S302. 0143

[0145] In step S304 it is determined whether the graphing conditions repeatedly. When it is determined photographer switches the photograph preparation switch (indicated by SW1 in the flowchart) on. While the photograph preparation switch is off, the CPU goes in step S304 that the photograph preparation switch becomes on, the CPU leaves step S304 to execute the back to step S303 to accept the setting of the photoprocesses in and after step S311.

The transmittance is approximately zero in

the low range of applied voltage, the transmittance and the transmittance becomes saturated at the applied Thus the optical element serves as an optismall applied voltage but transmits the light in the state

steeply increases with increase of the applied voltage,

voltage of V3.

[0135]

mittance of the optical element 301 against applied volt-

age to the optical element 301.

[0134]

Fig. 12 shows the relationship of light trans-

shutter presents its open state.

0133]

that is, the optical switch goes into the open state, as explained with Fig. 12, so as to allow the photograph In step S312 the image pickup means 134 and signal age V3 to the optical element 301. Then the transmittance of the optical element 301 becomes maximum, light to pass through the photographing optical system. processing circuit 145 are actuated to capture the pre-In step S311, the output voltage of the power supply means 144 is controlled to V3 to apply the volt-[0146] 8

Fig. 13 shows an application example of the

of the applied voltage of V3.

[0136]

cal shutter which intercepts the light in the state of very

optical element 301 to the photographing apparatus. In

the present embodiment the photographing device 341 will be described as an example of the digital still camera similar to that in Embodiment 1. Numeral 330 designates the photographing optical system consisting of a plurafity of tens units, which are a first lens unit 331, a

second lens unit 332, and a third lens unit 333 the func-

tion of each of which is the same as each lens unit 131,

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When it is determined in this step that the In step S315 the preview image captured in step S312 is displayed on the monitor 151. In next step S316 the focus condition of the photographing optical ight amount level is proper, the CPU goes to step S315. system 330 is detected by the focus detector 154. [0148] [0149]

In next step S317, the CPU makes the focus driver 155 move the first lens unit 331 back and forth in the optical-axis directions to perform the focusing oper-[0150]

After that, the CPU goes to step S318 to determine whether the photograph switch (indicated by SW2 in the flowchart) is switched on. While the photograph switch is off, the CPU returns to step S311 to repeatedly carry out the steps from the acquisition of preview image to the focusing. [0151]

On the other hand, when it is determined in step S314 that the light amount level determined in step In step S321 the CPU compares the actual light amount level with the proper light amount level and increases or S313 above is not proper, the CPU jumps to step S321. decreases the aperture diameter of the stop means 334 In the photographing optical system 330. [0152]

the acquisition of preview image to the stop aperture After execution of step S321, the CPU goes back to step S312 to repeatedly carry out the steps from control until the light amount level of the incident light to the image pickup means 134 becomes proper. [0153]

Once the light amount level of the incident light to the image pickup means 134 becomes proper, the CPU transfers from step S314 to step S315. [0154]

graph switch on during the repetitive execution of the photograph preparation operation as described above, When the photographer switches the photothe CPU jumps from step S318 to step S331. [0155]

In step S331 the image pickup operation is carried out. Specifically, the object image focused on the image pickup means 134 is photoelectrically converted and the charge proportional to the intensity of the optical image is accumulated in the charge storage por-tion near each photoreceptive portion. In step S332 the trolled to zero to cancel the application of the voltage to output voltage of the power supply means 144 is conthe optical element 301. [0156]

Then the optical element 301 goes into the minimum state of transmittance, as described with Fig. graphing optical system. In step S333 the charge stored 12, so as to intercept the light traveling in the photon step S331 is read out through the charge transfer line [0157]

and the analog signats read out are suppiled to the slgnal processing circuit 145. In general, detrimental noise will be likely to optical element 301 during the charge transfer, so that occur in the image signals if light enters the photoreceptive portions during the transfer of the stored charge from the image pickup means. In the present embodiment the light is intercepted in step S332 above by the the detrimental noise can be prevented from occurring in the image. [0158]

In S334 the signal processing circuit 145 nais received and the image processing thereof such as according to the image compression program stored in performs the A/D conversion of the analog image sigthe AGC control, white balance, y correction, edge enhancement, and so on. The signal processing circuit 145 further performs the JPEG compression or the like the CPU 342 if necessary. [0159]

In step S335 the CPU stores the Image sigand the photographing operation is complete in step nals obtained in step S334 above into the memory 156 [0160] S336.

Embodiment 3 described above can realize the optical element or the photographing apparatus that can present the excellent effects in terms of the following points. [0161]

The present embodiment can provide the optical shutter capable of switching between the transmission state and the interception state of light by controffing the applied voltage to the optical element.

The use of the optical element instead of the mechanical shutter mechanism of the photographing optical system permits disuse of the mechanical means such as the shutter wings, the shutter wing driving mechanism, and the like and also permits achievement of the smaller size of the photographng apparatus.

the optical element 401 and entering the aperture of the

element 401

[0170]

uid 422 is t1. L_{IN} represents the light coming from above stop 207, and L_{OUT} the light emerging from the optical Since the first liquid 421 exhibiting the lens shape has the predatermined light absorptive power in the output light Lour is not uniform, the light transmittance is minimum on the optical axis 123, and the transmitted light amount increases with increase in the

[Embodiment 4]

the application example as an apodization filter having the gradually decreasing transmittance with increase in filter capable of presenting the transmittance distribuincrease in the incident height of the incident light to the tance distribution to a desired profile by controlling the Embodiment 2 described previously showed the incident height of the incident light to the optical element, whereas Embodiment 4 demonstrates an example of application to a transmittance-distribution-variable tion in which the transmittance gradually increases with optical element and capable of controlling the transmitapplied voltage to the optical element. [0162]

Figs. 15A, 15B, and 15C to Fig. 18 are draw-Ings for explaining Embodiment 4 of the present invention and Flgs. 15A to 15C are diagrams for detailing the operation where the optical element in the present embodiment is used as a transmittance-distribution-var-[0163]

surface of the droplet of the first liquid 421 is reduced to tact with the hydrophilic film 113 formed on the bottom

surface of the cover sheet 106.

The diameter of this flat part is smaller than the diameter D4 of the aperture of the stop 207. As a result, the transmittance is uniform in the area inside the insulating layer 104, water-repellent film 111, first liquid flat part and gradually increase with Increase in the distance from the optical axis in the outside area. The transmittance at the incident height of zero at this time is expressed by the product of the transmittances of the transparent substrate 102, transparent electrode 103, EP 1 069 450 A2 to1 are different in their property from the liquids in the

Embodiment 1 to Embodiment 3 in that the first liquid

The present embodiment is different from 121 and the second liquid 422 in the optical element

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water-soluble dye in Embodiment 1 to Embodiment 3, ment does not contain the dye and is thus transparent. ment 1 to Embodiment 3, whereas an oil-soluble dye is added in a predetermined concentration to the first liq-

First, the second liquid 122 contained the whereas the second liquid 422 of the present embodi-Further, the first liquid 121 was transparent in Embodi-

other embodiments.

from the power supply means 126 to the optical element tance distribution against incident height (distance from the optical axis 123) of the incident light to the optical Fig. 16 shows the relationship of transmitelement 401, using the parameter of the applied voltage [0174] <u></u>

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The dye is preferably one selected from

uid 421 in the present embodiment.

In general, such pigments are colored in blue, yellow, red, etc., and an achromatic pigment can be obtained by mixing some of them at a predetermined and dimensions as in Embodiment 1 to Embodiment 3. Therefore, the same portions will be denoted by the

[0167]

chelate azo pigments and nitroso pigments.

421, hydrophillc film 113, and cover sheet 106, and the

light absorptive power of the first liquid 421 becomes

dominant.

With increase in the applied voltage, the average transmittance decreases and absolute values of gradients increase on the transmittance curves in which the transmittance gradually increases with increase in the incident height. [0175]

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same numbers and redundant description will

The stop 207 has the same aperture diame-

[0168] [0169]

Fig. 15A shows a situation in which the output voltage of the power supply means 126 connected

ter D4 as the stop 207 of Embodiment 2.

to the optical element 401 is V1 equal to or close to zero. The shape of the interface 124 at this time is the

same as in Fig. 7A, the diameter of the bottom surface

of the droplet of the first liquid 421 is A1, and the height is h1. The thickness on the optical axis of the second liq-

ratio. The other members all have the same functions

Fig. 17 shows an application example of the optical element 401 to the photographing apparatus. In the present embodiment, the photographing device 441 will be described as an example of the so-called silversaft still camera for recording a still image in a silver film, as in Embodiment 2. ĸ

Numeral 430 designates the photographing and a third lens unit 433, each lens having the same 232, or 233 in the photographing device 241 in Embodwhich are a first lens unit 431, a second lens unit 432, function but different power from each lens unit 231, optical system consisting of a plurality of lens units, iment 2 of Fig. 9. [017] 8

between the second lens unit 432 and the third lens unit third lens unit 433. The silver film 236 is disposed at the position of the focal point of the photographing optical system 430 and the focal-plane shutter 235 is placed immediately before the silver film. The other structure is the same as in the photographing device 241 of Embod-The mechanical stop mechanism 434 using the stepping motor as a driving source is interposed 433, and the optical element 401 is placed behind the ş

the present embodiment, the light amount distribution of

Fig. 15B shows a situation in which the out-

distance from the optical axis 123.

than V1. At this time, the diameter of the bottom surface of the droplet of the first liquid 421 is A2 and the height than in Fig. 15A and the nonuniformity of transmitted

is h2. The average transmitted light amount is smaller

Fig. 15C shows a situation in which the output voltage of the power supply means 126 is V3 further greater than V2. At this time, the diameter of the bottom 43 and the top of the interface 124 becomes flat in con-

light amount also becomes more prominent.

put voltage of the power supply means 126 is V2 greater

Next, the action of the optical element 401 in the present embodiment will be described. The illuminance of the object image formed on the film 236 by the which the illuminance is high in the center and of the decrease in the marginal light amount at this time are substantially uniquely determined by the zoom condition and stop condition of the photographing optical called marginal light amount decrease phenomenon in decreases with the distance from the center. Amounts system. On the other hand, the transmittance distribution against the incident height of the optical element photographing optical system 430 demonstrates the soiment 2 and the description thereof is omitted herein. [0179]

properly compensated for by placing the optical element the transmittance distribution for compensation for the zoom condition and the stop condition. Specifically, Therefore, the marginal light emount decrease of the image on the film surface 236 can be 401 at an appropriate position in the photographing optical system and providing the optical element 401 with marginal light amount decrease determined by the experiments are conducted on the occasion of production of the photographing device 441 to determine the marginal light amount decrease data according to each of zoom conditions and stop conditions and determine the optimum applied voltage to the optical element 401 for compensation for it. [0180]

8 CPU 442 and the applied voltage to the optical element Then the applied voltages according to the respective zoom conditions and stop conditions are stored in the form of a look-up table in the ROM in the 401 is controlled by reading a value from the table during photography. [0181]

Fig. 18 is a control flowchart of the CPU 442 The control flow of the photographing device 441 will be described below referring to Fig. 17 and Fig. in the photographing device 441 illustrated in Fig. 17. [0182] [0183] ĕ

Through step S401, the CPU goes to step main switch on. While the main switch is off, the CPU S402 to determine while the photographer switches the stays at step S402. [0184]

In step S403 the CPU accepts the photo-(single shot, continuous shots, etc.) and so on by use of When it is determined in step S402 that the main switch becomes on, the CPU 442 leaves the sleep graphing conditions set by the photographer. Specifically, the photographer sets the exposure control mode (shutter priority AE, program AE, etc.), the autofocus mode (one shot AF, continuous AF, etc.), the drive mode state to execute the processes in and after step \$403. the monitor 251 and the control switches 252. [0186] [0185]

photograph preparation switch is off, the CPU goes in step \$404 it is determined whether the graphing conditions repeatedly. Once it is determined in becomes on, the CPU leaves step S404 to execute the photographer switches the photograph preparation switch (indicated by SW1 in the flowchart) on. While the step S404 that the photograph preparation switch back to step S403 to accept the setting of the photoprocesses in and after step S411. [0187]

in step S411 the CPU determines the zoom the CPU calculates the shutter speed and aperture In step S412 the object luminance is detected by the photometry means 256. In step S413 upon photography, based on the object luminance condition of the photographing optical system 430. [0188] [0189]

In stap S414, the CPU reads the voltage to

[04190]

detected and the program chart stored in the ROM.

be applied to the optical element 401 out of the look-up the photographing optical system 430 determined in table stored in the ROM, based on the zoom condition of step S411 above and the aperture upon photography computed in step S413.

S414 above is supplied from the power supply means tion is effected for the marginal light amount decrease of [0191] in step S415, the voftage thus read in step 144 to the optical element 401. As a result, compensathe photographing optical system 430.

In step S416 the focus condition of the photographing optical system 430 is detected by the focus detector 154. [0192]

driver 155 move the first lens unit 431 back and forth in In next step S417, the CPU makes the focus the optical-axis directions to perform the focusing opermine whether the photograph switch (indicated by SW2 in the flowchart) is switched on. While the photograph switch is off, the CPU goes back to step S411 to carry out the steps from the zoom condition determination to ation. After that, the CPU goes to step S418 to deterthe focusing repeatedly. [0193]

graph switch on during the repetitive execution of the the CPU jumps from step S418 to step S431. In step S431 the quick return mirror 427 is retracted out of the When the photographer switches the photophotograph preparation operation as described above, [0194]

In step S432 the stop 434 is controlled photograph light. [0195]

actuated and controlled, based on the shutter speed [0196] In step S433, the focal-plane shutter 425 is calculated in step S413. In step S434, the quick return mirror 247 is returned into the photograph light and the based on the aperture calculated in step S413. stop 434 is also returned into the open state.

In step S435 the charger 245 is actuated to one frame. The photographing operation is complete in charge the focal-plane shutter 235 into the initlal state (wing-movable state) and the film 236 is wound up by step S436. [0197]

Embodiment 4 described above can realize the optical element or the photographing apparatus that can present the excellent effects in the following points. [0198]

- dent height of the incident light to the optical The present embodiment can provide the transmittance-distribution-variable filter that can implement the transmittance distribution in which the transmitlance gradually increases with increase in the incietement and that can control the transmittance distribution to a desired profile by controlling the applied voltage to the optical element.
- graphing apparatus that can capture a high-quality placing the optical element at the predetermined The present embodiment can provide the photoimage while decreasing the marginal light amount decrease of the photographing optical system, by position of the photographing optical system.

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Next, embodiments of the optical switch capable of changing the optical path (traveling direction) of incident light will be described below, but it is noted that the present invention is by no means intended to be imited to these embodiments.

[Embodiment 5]

Figs. 19A and 19B are cross-sectional views of the optical switch in Embodiment 5 of the present . 1020 1020

of the ing layer 14, a first liquid 15 and an electrolyte solution prisms 11 and 12, and an opposed electrode 17 as a present embodiment is composed of a first prism 11 as conductive electrode 13 as a first electrode, an insulat-16 as an electroconductive, second liquid, the liquids being confined in a sealed space created between the a support, a second prism 12, a transparent, electro-In the figures, the optical switch second electrode. The prisms 11, 12 made of an optical material having the refractive index np are rectangular prisms and the electrode 13 is the transparent, electroconducfor example, by sputtering or by the Electron Ream tive electrode of ITO or the like formed on the prism 11, [0203]

The transparent insulating layer 14 is formed parent, electroconductive electrode 13, pressing a glass in the thickness of about 20 µm on the electrode 13 by dropping the replica restn (model number C001 available from Dai Nippon Printing Co., Ltd.) onto the transsheet thereonto, and thereafter exposing it to UV light for fifteen minutes.

14 are desirably equal to that np of the prisms 11 and The refractive indexes of the transparent, electroconductive electrode 13 and the insulating layer [0205]

solution 16 is preferably equal to that of the first liquid 15 electrolyte solution 16 of NaCi aqueous solution (3.0 wt%) the specific gravity of which is adjusted to be substantially equal to that of the first liquid 15 are confined between the prism 11 with the transparent, conductive within the scope of ±10%, and the equality in this range is regarded as "substantially equal" in the present specification. The contribution of the gravity to the shape of The first liquid 15 of silicone oil TSF437 (available from Toshiba Silicones Co., Ltd.) and the electrode 13 and the insulating layer 14 formed thereon, and the prism 12. The specific gravity of the electrolyte [0206]

by equalizing the specific gravities of the first liquid 15 the interface between the two liquids can be eliminated and the electrolyte solution 16 as described above. [0207] It is necessary to pay attention to avoiding ing the confining operation of the first liquid 15 and the rolyte solution 16 thus confined, the space between the prisms 11 and 12 is sealed by the opposed electrode 17 electrolyte solution 16 between the prisms 11 and 12. For preventing leakage of the first liquid 15 and the eleccontact between the first liquid 15 and the prism 12 durand the sealant 18 such as a glass sheet or the like.

total reflection against the refractive index np of the The refractive index nA of the electrolyte solution 16 is desirably set to satisfy the condition of The first liquid 15 is a liquid immiscible with prisms 11, 12 (np » nA). [0208] [020]

ably substantially equal to that np of the prisms 11, 12 the electrolyte solution 16; e.g., silicone oil or the like, and the refractive index ng of the first liquid 15 is desir-(np = ng). 8

In the state of V = 0 where no voltage is applied to the electrolyte solution 16, i.e., where no voti-19A), only the electrolyte solution 16 is in contact with lyte solution 16 and the refractive index no of the prism 12 satisfy the condition of total reflection. Therefore, the incident light is totally reflected at the interface between age is placed between the transparent, conductive electhe prism 12, and the refractive index n_A of the electrotrode 13 and the opposed electrode 17 of nickel (Fig the prism 12 and the electrolyte solution 16. [0210] x 8

the electrolyte solution 16 to deform the interface, and to that np of the prism 11 and the prism 12, the incident of the first liquid 15 is always constant, independent of When a voltage is placed between the transparent, conductive electrode 13 and the opposed electrode 17 of nickel (Fig. 19B), i.e., when $V = V_0$, the interfacial tension varies between the first liquid 15 and the first liquid 15 goes into contact with the prism 12. Since the refractive index n_B of the first liquid 15 is equal light travels through them. On this occasion, the volume [0211]

prisms and are made of a material selected from be made of a conductive, transparent material, such as between the prisms 11, 12 can be an aqueous solution The prisms 11, 12 are the rectangular polycarbonate, and acrylic resin. The indexes of the transparent, conductive electrode 13 and the insulating and 12. The transparent, conductive electrode 13 can ITO, tin oxide, or the like. The insulating layer 14 can be a layer of acrylic resin formed by the replica method, or vapor deposition. The electrolyte solution 16 confined of an electrolyte such as NaCl, Na2SO4, or the like, or a layer 14 are desirably equal to that no of the prisms 11 a layer of polytetrafluoroethylene or another fluorinetreated polymer deposited by sputtering or by chemical glasses or plastics such as polytetrafluoroethylene, polar liquid such as water, alcohol, acetone, formamide, or ethylene glycoi, or a mixture of either of such polar the voltage applied to the two electrodes. [0212] ŧ

solution 16 is desirably set to satisfy the condition of The first liquid 15 is the liquid immiscible with ver, and indium/tin oxide and can be formed in the flatplate or rodlike shape as long as it is in contact with the etectrolyte solution 16. The sealant 18 can be made of ike shape as long as it can seal the space between the The refractive index nA of the electrolyte the electrolyte solution 16, for example, like silicone oil. The opposed electrode 17 can be made of a material selected from gold, platinum, stainless steel, nickei, sila material selected from glasses, acrylic resin, and metals and can be formed in the flat-plate, circular, or rodtotal reflection against that no of the prisms 11, 12.

absorbed by the first prism, so that the light is not transother opening by the sealant 18 of a giass sheet, but the Embodiment 5 is the optical switch for switching the optical path on the side of the first prism 11, whereas a modification of Embodiment 5 can be an a transparent body but an opaque body with a lightabsorbing property. When the voltage is placed between the transparent, conductive electrode and the with the prism 12, the incident light becomes In Figs. 19A and 19B one opening of the space is sealed by the opposed electrode 17 while the optical switch for switching the optical path on the second prism side. In the modification, the first prism is not opposed electrode 17 to bring the first liquid 15 into conboth openings may also be sealed by the giass sheet. mitted by the first prism. [0215] [0216]

[Embodiment 6]

8 [0217] Figs. 20A to 20C are cross-sectional views of the optical switch in Embodiment 6 of the present

In the figures, the optical switch of the present embodiment is composed of first and second substrates 21, 22, a transparent, electroconductive a first figuid 25 and an electrolyte solution 26 as a second liquid, the two liquids being confined between the The substrates 21, 22 are made of an optical electrode 23 as a first electrode, an insulating layer 24, substrates 21 and 22, and an opposed electrode 27. [0218] [0219]

material having the refractive index np and the electrode 23 is a transparent, electroconductive electrode of TO or the like formed on the substrate 21, for example, by sputtering or by the Electron Beam method.

The transparent insulating layer 24 is formed in the thickness of about 20 µm on the electrode 23 by ole from Dai Nippon Printing Co., Ltd.) onto the transthereonto, and thereafter exposing it to UV light for fifdropping the replica resin (model number C001 availaparent, conductive electrode 23, pressing a glass sheel teen minutes. The refractive indexes of the transparent, conductive electrode 23 and the insuiating layer 24 are

The first liquid 25 of silicone oil TSF437 (available from Toshiba Silicones Co., Ltd.) and the electrolyte solution 26 of NaCl aqueous solution (3.0 stantially equal to that of the first liquid 25 are confined between the substrate 21 with the transparent, conductive electrode 23 and the insulating layer 24 formed and the substrate 22 on the occasion of confining the first liquid 25 and the electrolyte solution 26. The space between the substrates 21, 22 is sealed by the sealant 28 of the giass sheet or the like in order to avold leakage of the first liquid 25 and the electrolyte solution 26 thus wt%) adjusted so that the specific gravity thereof is subthereon, and the substrate 22. It is necessary to pay attention to avoiding contact between the first liquid 25 desirably equal to that np of the substrates 21 and 22. [0222]

The first liquid 25 is the liquid immiscible with the electrolyte solution 26, e.g., like silicone oil. confined. [0223]

The refractive index ng of the electrolyte solution 26 is desirably equal to that np of the substrates 21, 22 ($n_P \approx n_B$). [0224]

placed between the transparent, conductive electrode 23 and the opposed electrode 27 of nickel (Fig. 20A), 1.49, and the refractive index of the electrolyte solution 36 is 1.34. Therefore, the incident light passing through a slit 29a of a slit sheet 29 is refracted at the interface between the first liquid 25 and the electrolyte solution 26 In the state of V = 0 (V) where no voltage is the electrolyte solution 26 is in contact with the substrate 22. The refractive index of the first liquid 25 is to reach a photoreceptive portion 20a on a photoreceptive sensor substrate 20. [0225]

parent, conductive electrode 23 and the opposed electrode 27 of nickel (Fig. 20B), i.e., when V=V1, the interfactal tension varies between the first liquid 25 and the electrolyte solution 26, and thus the shape of the interface is altered between the first liquid 25 and the ejectrolyte solution 26, so as to decrease the radius of curvature of the electrolyte solution 26. Therefore, the incident light is refracted at a larger angle to reach a [0226] When a vottage is placed between the transphotoreceptive portion 20b.

When a further higher voltage is applied (Fig. 20C), i.e., when V = V2, the first liquid 25 goes into substrate. Since the refractive index n_A of the first liquid 25 is equal to that np of the substrates 21 and 22, the contact with the second substrate 22 being the upper incident light is not refracted and thus reaches a photoreceptive portion 20c. [0227]

In this way the optical path of light can be deflected by controlling the voltage in the present embodiment. Here the difference between the refractive indexes of the first liquid 25 and the electrolyte solution 26 is desirably not less than 0.1 in order to achieve the efficient refraction of incident light. [0228]

The materials used in Embodiment 6 can be the same as in Embodiment 5. [0229]

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Figs. 21A and 21B are cross-sectional views of the optical switch in Embodiment 7 of the present

electrode 33, an insulating layer 34, a first liquid 35 and In the figures, the optical switch of the present embodiment is composed of first and second substrates 31, 32, a transparent, electroconductive an electrolyte solution 36 as a second liquid, the two liquids being confined between the substrates 31 and 32, and an opposed electrode 37.

are formed in a surface on the liquid chamber side of the The substrates 31, 32 are made of an optical material having the refractive index np and microprisms substrate 32.

The electrode 33 is a transparent, electroconductive electrade of ITO or the like formed on the substrate 31, for example, by sputtering or by the Electron Beam method. [0233]

parent, conductive electrode 33, pressing a glass sheet The transparent insulating layer 34 is formed thereonto, and thereafter exposing it to UV light for fif-In the thickness of about 20 µm on the electrode 33 by ble from Dai Nippon Printing Co., Ltd.) onto the transdropping the replica resin (model number C001 availateen minutes. [0234]

desirably equal to the refractive index np of the subconductive electrode 33 and the insulating layer 34 are The refractive indexes of the transparent, strates 31 and 32. [0235]

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wr%) adjusted so that the specific gravity thereof is equal to that of the first liquid 35 are confined between The first liquid 35 of silicone oil TSF437 (available from Toshiba Silicones Co., Ltd.) and the electrolyte solution 36 of NaCl aqueous solution (3.0 the substrate 32, and the substrate 31 with the transparent, conductive electrode 33 and the insulating layer 34 formed thereon. [0236]

S Index nA of the first liquid 35 is desirably equal to that np It is necessary to pay attention to avoiding contact between the first liquid 35 and the prism 32 on the space is sealed between the substrates 31 and 32 solution 36, for example, like silicone oil. The refractive the occasion of confining the first liquid 35 and the electrolyte solution 36. In order to avoid leakage of the first by the sealant 38 of a glass sheet or the like. The first iquid 35 is the liquid immiscible with the electrolyte liquid 35 and the electrolyte solution 36 thus confined, of the substrates 31 and 32 (np ≈ nA).

strate 32 and thus the incident light is refracted at the [0238] When no voltage is placed between the interface between the substrate 32 and the electrolyte solution 36. The direction of refraction can be controlled by changing the pattern of the substrate 32 on the liquid transparent, conductive electrode 33 and the opposed electrode 37 of nickel (Fig. 21A), i.e., when V = 0 (V), the electrolyte solution 36 is in contact with the sub-

chamber side.

the substrate 32. At this time, since the refractive index trode 37 of nickel (Fig. 21B), i.e., when $V = V_0$ (V), the interfacial tension varies between the first liquid 35 and tion 36, whereby the first liquid 35 goes into contact with n_A of the first liquid 35 is equal to the refractive index n_P of the substrates 31 and 32, the incident light travels When a voltage is placed between the transparent, conductive electrode 33 and the opposed electhe electrolyte solution 36 to alter the shape of the interface between the first liquid 35 and the electrolyte solu-

The materials used in Embodiment 7 can be the same as in Embodiment 5. [0240]

straight.

Since the optical switches described above devices can be constructed in compact size. Since the ting phenomenon, the switching of optical path can be in Embodiments 5 to 7 do not require any mechanical driving mechanism for switching of optical path, the optical path is changed by malding use of the electrowetachieved efficiently. [0241] 5

Claims

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 An optical element having a first fluid and a second fluid immiscible with each other, which are confined in a sealed space created between a first support and a second support, said second fluid being electroconductive or polar, said optical element being characterized in that: said first fluid and said second fluid have respective light transmittances different from each other; and,

fluid, the shape of an interface between said first fluid and said second fluid is altered, so as by varying a voltage applied to sald second to change an amount of light passing through said optical element. The optical element according to Claim 1, further તં

a first electrode kept in an electrically insulating

a second electrode kept in an electrically conducting state to said second fluid, state from said second fluid; and

said first fluid and said second fluid is altered by varying the voltage applied between said wherein the shape of the interface between first electrode and said second electrode.

substantially uniformly, independent of positions of The optical element according to either one of Claims 1 and 2, wherein the amount of the light passing through said optical element is changed the light passing through said optical element. લં

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- shape, wherein optical path lengths of rays a stop having an aperture of predetermined substantially equal to each other, independent of positions of the rays passing through said passing through the aperture of said stop inside sald first liquid and said second fluid are
- a desired distribution according to positions of the The optical element according to either one of Claims 1 and 2, wherein the amount of the light passing through said optical element is changed in light passing through said optical element. 'n
- The optical element according to either one of Claims 1, 2, and 5, further comprising: ø,

a stop having an aperture of predetermined shape, wherein optical path lengths of rays passing through the aperture of said stop inside said first liquid and said second fluid differ depending upon positions of the rays passing through sald aperture.

- The optical element according to either one of Claims 1 to 6, wherein said first fluid is placed on a substrate having the water-repellent property. ۲.
- The optical element according to either one of Claims 1 to 7, wherein at least one of said first and second fluids has the light absorbing property.
- The optical element according to either one of Claims 1 to 8, wherein specific gravities of said first fluid and said second fluid are substantially equal to
- 10. An optical device characterized by comprising:

an optical element according to any preceding an optical system for guiding light from an claim for changing an amount of light passing object to a predetermined position; and through said optical system.

fluid immiscible with each other, which are confined troconductive or polar, said optical element being An optical element having a first fluid and a second in a sealed space created between a first support and a second support, said second fluid being elec-

fluid, the shape of an interface between said first fluid and said second fluid is attered, so as by varying a voltage applied to said second

to change an optical path of incident light entering said optical element. The optical element according to Claim 11, further comprising: a first electrode kept in an electrically insulated said first fluid and said second fluid is altered by varying the voltage applied between said a second electrode kept in an electrically conwherein the shape of the interface between first electrode and said second electrode. state from said second fluid; and ducting state to said second fluid,

The optical element according to either one of Claims 11 and 12, wherein said first fluid, which is spaced through sald second fluid from said second support in a state in which no voltage is applied to said second fluid, is brought into contact with said ond fluid, whereby the reflectance is varied at an Interface between said second support and said second support by applying the voltage to said secsealed space, so as to change the optical path of the Incident light entering said second support. Ę

The optical element according to either one of Claims 11 to 13, wherein a difference between a index of said second support satisfies the total refractive index of said second fluid and a refractive reflection condition for said incident light. 4

The optical element according to either one of Claims 11 to 14, wherein said first support is an opaque body having the light absorbing property. 5.

The optical element according to either one of Claims 11 and 12, wherein said first fluid, which is spaced through said second fluid from said second support in a state in which no voltage is applied to ond fluid, whereby said incident light is made to said second fluid, is brought into contact with said second support by applying the voltage to said sectravel straight through the optical element. 9

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The optical element according to either one of microprisms in a state in which no voltage is applied said microprisms by applying the voltage to said second fluid, whereby said incident light is made to Ciaims 11 and 12, wherein microprisms are formed at predetermined pitches on the said space side of said second support and wherein said first fluld, which is spaced through said second fluid from said to said second fluid, is brought into contact with travel straight through the optical element. 4.

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The optical element according to either one of Claims 11 to 17, wherein specific gravities of said . 8

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first fluid and said second fluid are substantially equal to each other.

- Ciaims 11 to 18, wherein said second support and The optical element according to either one of said first fluid have respective indexes of refraction substantially equal to each other.
- Claims 11 and 12, wherein a difference between 20. The optical element according to either one of refractive indexes of said first fluid and said second fluid is not less than 0.1.
- 21. An optical device characterised by comprising:

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an optical system for guiding light from an an optical element, according to any preceding claim 11-20, for changing an amount of light object to a predetermined position; and passing through said optical system.

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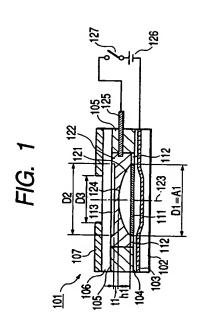
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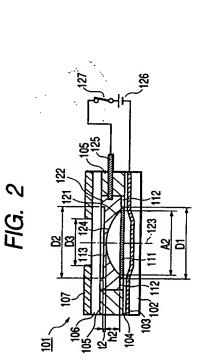
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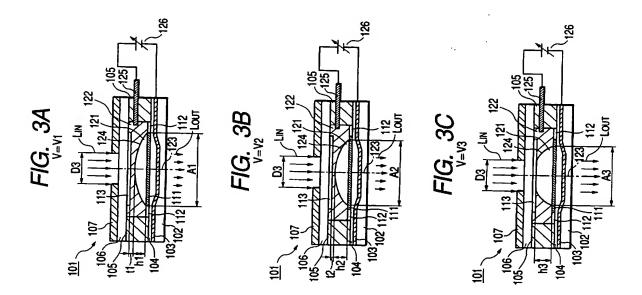
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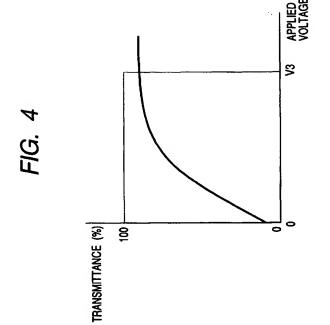
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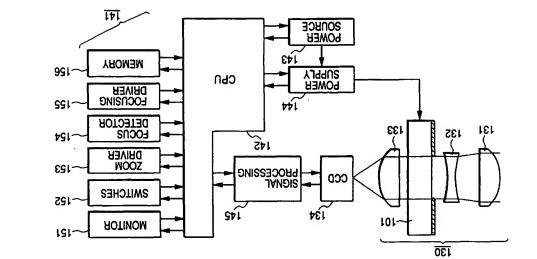




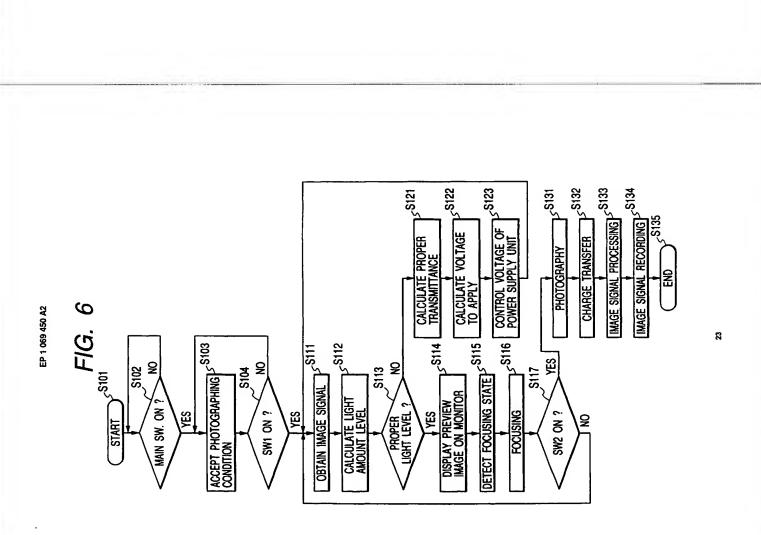


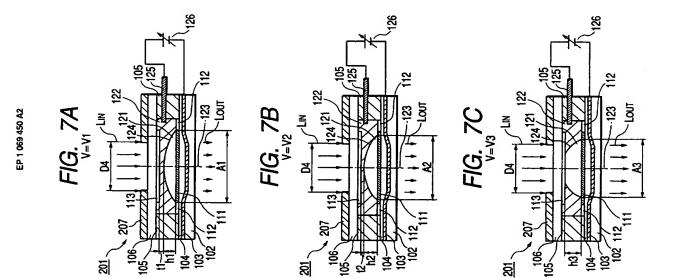


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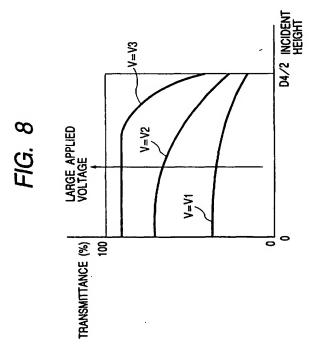


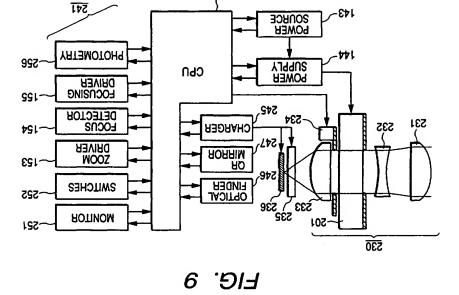
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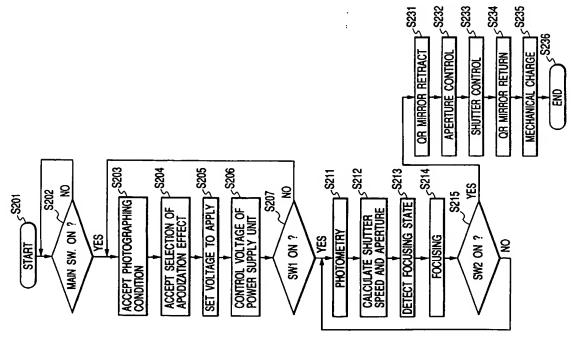


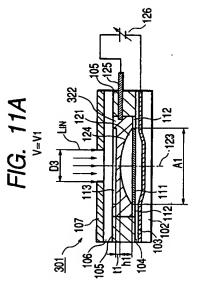


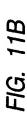
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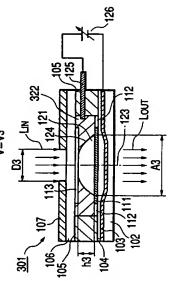
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FIG. 10

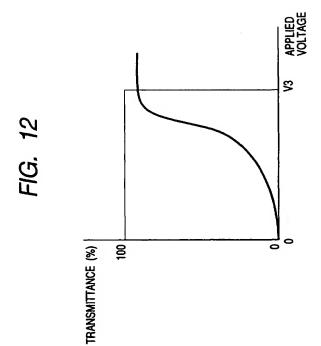












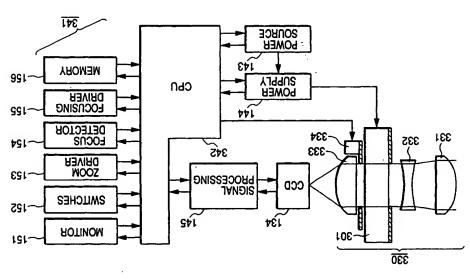
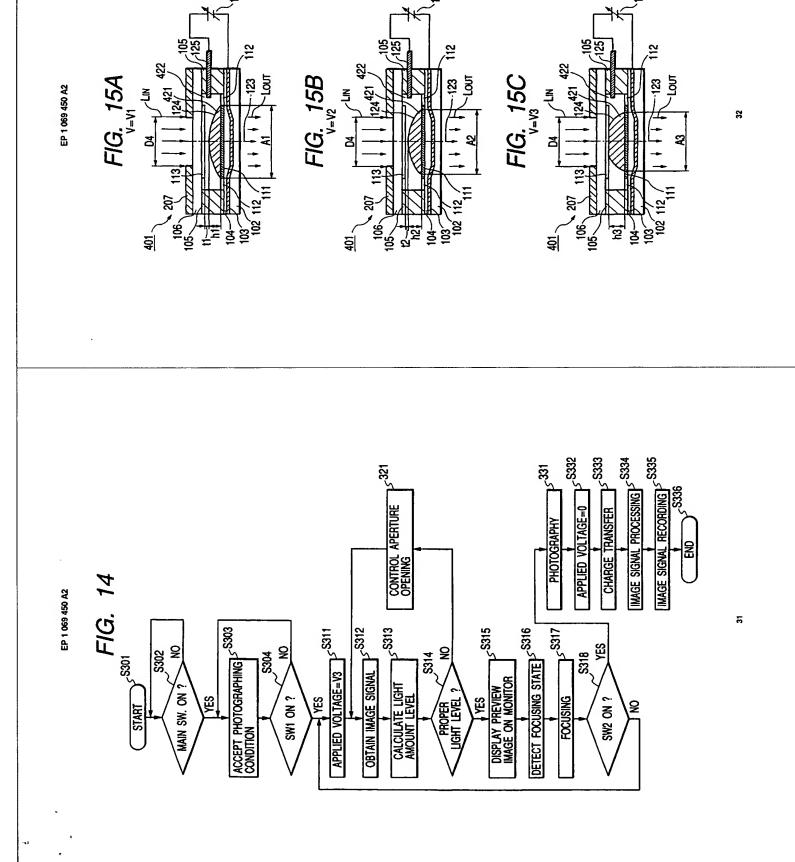


FIG. 13

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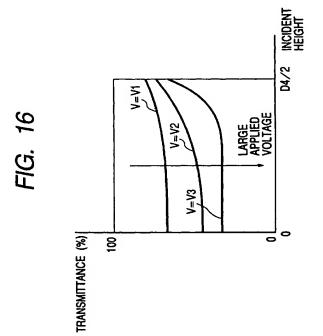
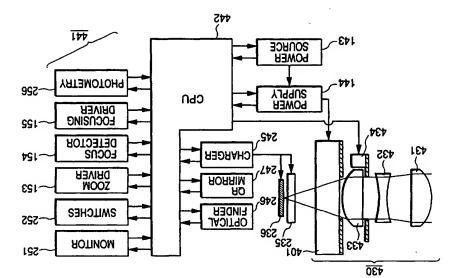


FIG. 17



OR MIRROR RETRACT APERTURE CONTROL OR MIRROR RETURN SHUTTER CONTROL FIG. 18 EP 1 069 450 A2 17887 CONTROL VOLTAGE OF POWER SUPPLY UNIT DETECT FOCUSING STATE S416 S414 ACCEPT PHOTOGRAPHING S403 CONDITION S412 S413 <u>S</u> SA18 YES S401 CALCULATE SHUTTER SPEED AND APERTURE DETERMINE ZOOM CONDITION read voltage to be applied MAIN SW. ON ? **PHOTOMETRY** SW2 ON? SW1 ON? T YES **FOCUSING**

